



Applicant: Kiyoshi MURAKAMI

Title: SUBSTRATE INSPECTING METHOD AND SUBSTRATE INSPECTING APPARATUS USING THE METHOD

Application No.: 10/786,468

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Examiner: Arbes, Carl J.

Art Unit: 3729

**AMENDMENT AND REPLY UNDER 37 C.F.R. 1.111**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated October 4, 2005, concerning the above-referenced patent application.

**Amendments to the Specification** begin on page 2 of this document.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 6 of this document.

**Amendments to the Drawings** are discussed on page 9 of this document, and include a replacement formal drawing sheet and a marked-up drawing sheet showing changes made.

**Remarks/Arguments** begin on page 10 of this document.

Please amend the application as follows: